



January 9, 2002

To: Commissioner of Patents and Trademarks
Washington, D.C. 20231

Fr: George O. Saile, Reg. No. 19,572
20 McIntosh Drive
Poughkeepsie, N.Y. 12603

RECEIVED
JAN 31 2002
TC 1700

Subject:

Serial No. 09/993,069 11/14/01

Chun-Hung Kung

METHOD OF REPAIRING PSM TO KEEP
NORMAL TRANSMISSION RATE AND PHASE
ANGLE

Grp. Art Unit: 1756

INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation
In An Application.


The following Patents and/or Publications are submitted to
comply with the duty of disclosure under CFR 1.97-1.99 and
37 CFR 1.56. Copies of each document is included herewith.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first class
mail in an envelope addressed to: Commissioner of Patents and
Trademarks, Washington, D.C. 20231, on January 22, 2002.

Stephen B. Ackerman, Reg.# 37761

Signature/Date

 1/22/02

U.S. Patent 5,965,303 to Huang, "Method of Fabricating a Phase Shift Mask Utilizing a Defect Repair Machine," discloses a method for fabricating a phase shift mask utilizing a defect repair tool.

U.S. Patent 6,207,328 to Lin, "Method of Forming a Phase Shift Mask," discloses a method for forming a phase shift mask.

U.S. Patent 5,382,484 to Hosono, "Method of Correcting Defects in the Pattern of Phase Shift Mask," discloses a method to correct defects in a PSM including Ga stains.

U.S. Patent 6,042,738 to Casey, Jr. et al., "Pattern Film Repair Using a Focused Particle Beam System," discloses a pattern film repair method using a focused particle beam system.

Sincerely,

A handwritten signature in black ink, appearing to read 'SBA', is written over the word 'Sincerely,'.

Stephen B. Ackerman,
Reg. No. 37761